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3/23/02
Harrison

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By: 

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by
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ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
MAR - 7 2002
TECHNOLOGY CENTER 2800

Inventor: Hiroshi TANABE
Serial No.: 09/614,286
Filed: July 12, 2000
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner: Timothy J. Sutton
Group Art Unit: 2813

Assistant Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Sir:

Applicant hereby petitions for a one-month extension, a petition pursuant to 37
C.F.R. §1.136(a) and authorization to charge the requisite fee being enclosed.

In response to the Office Action dated October 31, 2001, please amend the subject
application as follows: